

a 2002 0086

The invention refers to optoelectronics, in particular to the obtaining of coaxial microwire.

The process for coaxial microwire obtaining consists in that it is manufactured a double vacuum-treated ampoule, including two coaxially placed ampoules, each of which is filled up with a corresponding material. After vacuum treatment and soldering the double ampoule is placed into a resistance furnace for subsequent microwire extending.

Claims: 1

Fig.: 2